

Attorney Docket: 071469-0307558
Client Reference: ES-038



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 2682

HIGUCHI et al.

Application No.: 10/812,347

Group Art Unit: 1765

Filed: March 30, 2004

Examiner: Chen, Kin Chan

Title: PROCESSING SYSTEM AND METHOD FOR TREATING A SUBSTRATE

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated January 11, 2006, the period for reply being extended to May 11, 2006 by the Petition for One-Month Extension of Time filed herewith, please amend the above-identified application as follows:

05/12/2006 HAL111 00000140 033975 10812347

01 FC:1251 120.00 DA